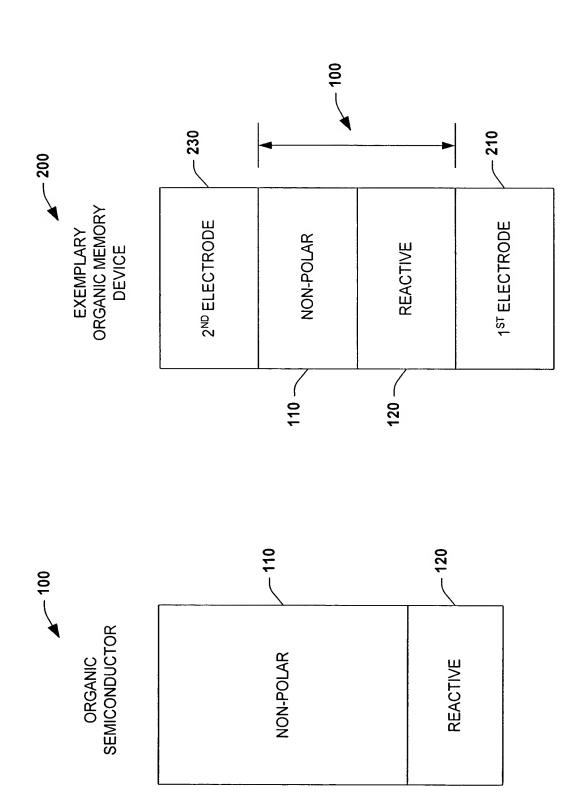
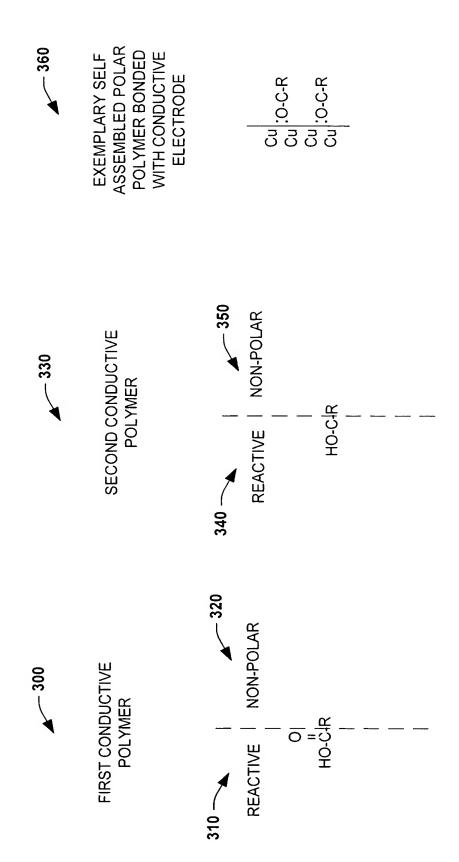


FIG. 2





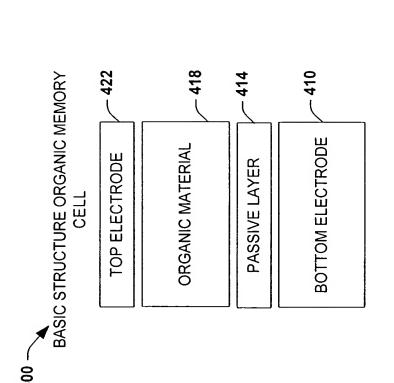


FIG. 4

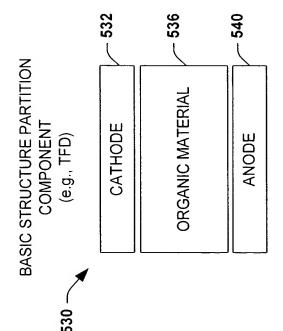
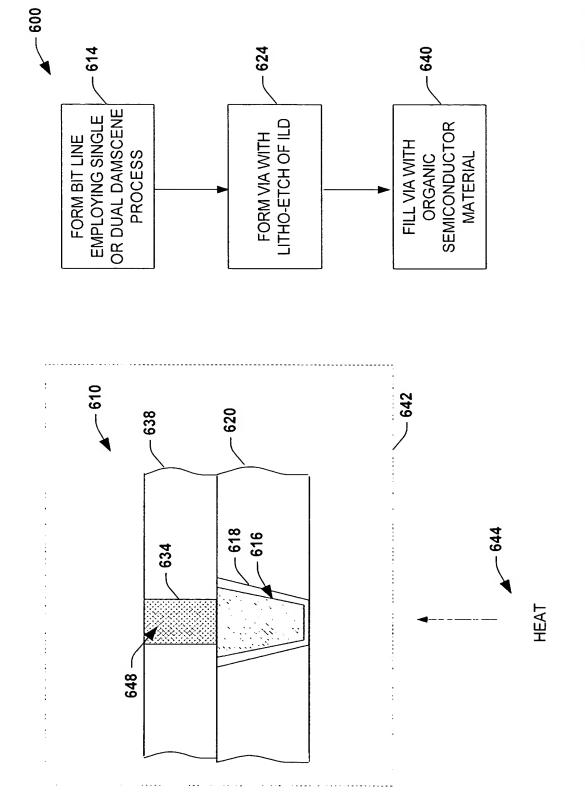
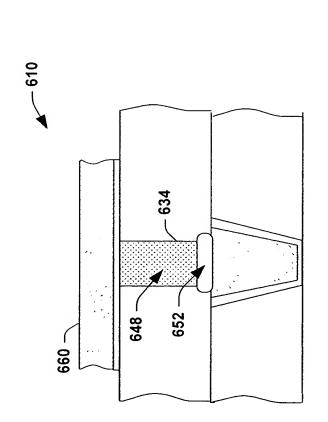


FIG. 5

FIG. 6

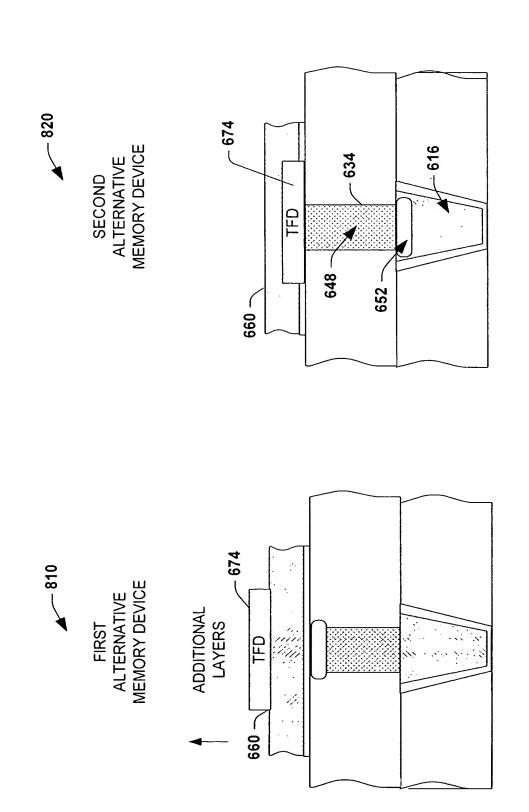


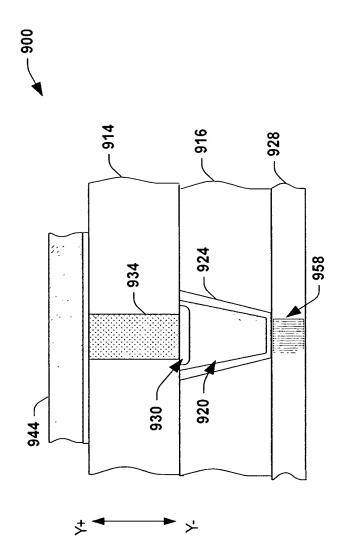


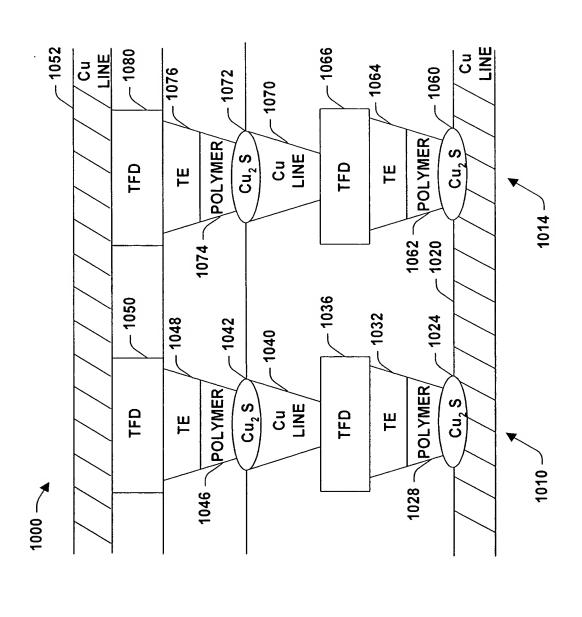
**- 650** 

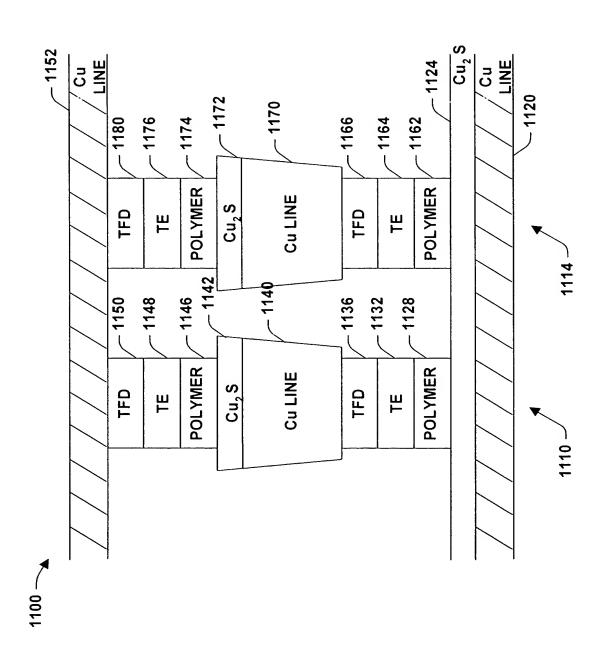
FORM PASSIVE LAYER ON TOP OF BIT - 656

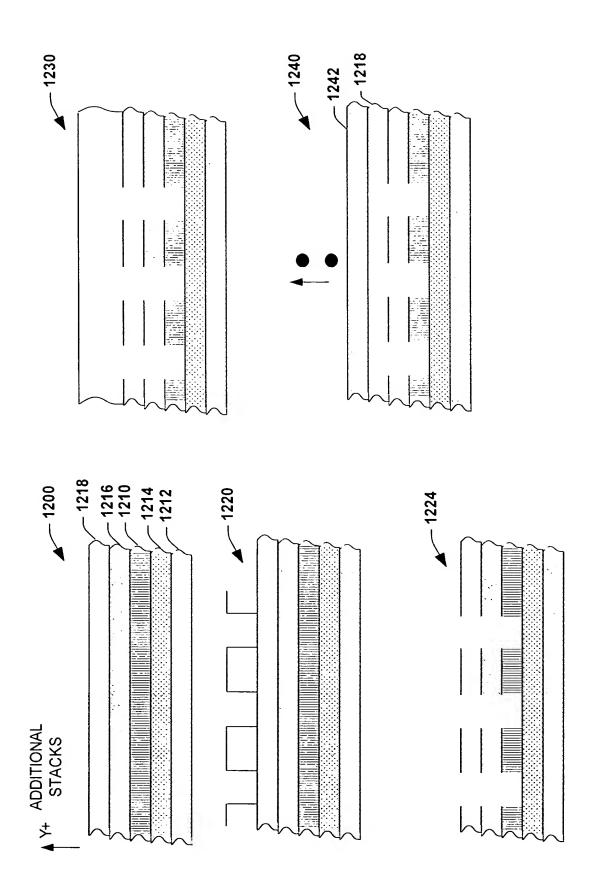
FORM ELECTRODE OVER ORGANIC SEMICONDUCTOR MATERIAL

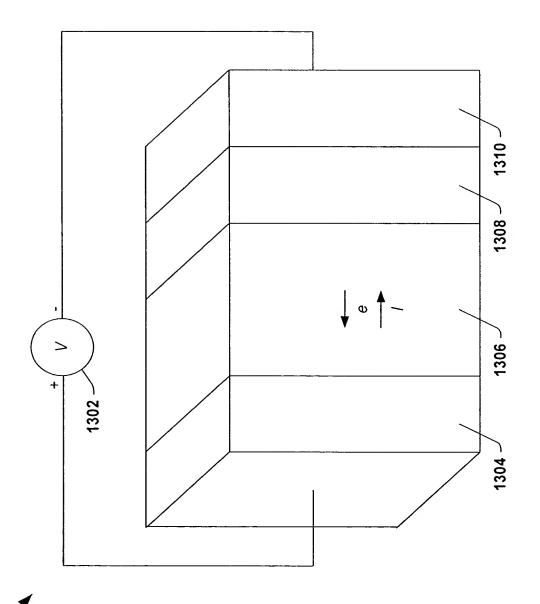












1300 🛧

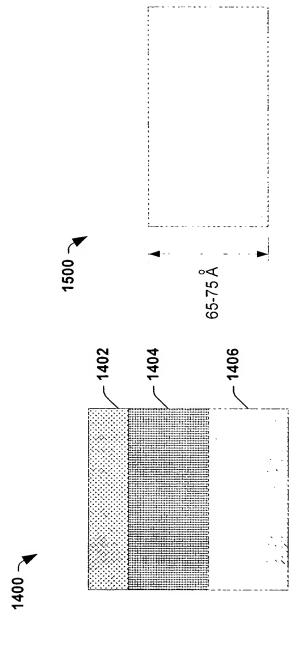


FIG. 14 FIG. 15

